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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/941,612	08/30/2001	Yoshinobu Aoyagi	1794-0141P	6758
2292 BIRCH STEW	7590 08/02/200 ART KOLASCH & BI	EXAMINER		
PO BOX 747		SONG, MATTHEW J		
FALLS CHURCH, VA 22040-0747			ART UNIT	PAPER NUMBER
			1722 ·	
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			NOTIFICATION DATE	DELIVERY MODE
			08/02/2007	ELECTRONIC

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

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		Application No.	Applicant(s)			
	•	09/941,612	AOYAGI ET AL.			
Office Action Summary		Examiner	Art Unit			
		Matthew J. Song	1722			
Period fo	The MAILING DATE of this communication app	ears on the cover sheet with th	e correspondence address			
A SH WHIC - Exte after - If NC - Failu Any	ORTENED STATUTORY PERIOD FOR REPLY CHEVER IS LONGER, FROM THE MAILING DA nsions of time may be available under the provisions of 37 CFR 1.13 SIX (6) MONTHS from the mailing date of this communication. Depriod for reply is specified above, the maximum statutory period were to reply within the set or extended period for reply will, by statute, reply received by the Office later than three months after the mailing ed patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICAT 36(a). In no event, however, may a reply built apply and will expire SIX (6) MONTHS 1, cause the application to become ABANDO	ION. e timely filed from the mailing date of this communication. DNED (35 U.S.C. § 133).			
Status	•					
1)⊠	Responsive to communication(s) filed on 26 Ju	<u>ıne 2007</u> .	·			
2a)⊠	This action is FINAL . 2b) ☐ This action is non-final.					
3)[Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
	closed in accordance with the practice under E	x parte Quayle, 1935 C.D. 11	, 453 O.G. 213.			
Disposit	ion of Claims					
5)□ 6)⊠ 7)□	Claim(s) 37-48 is/are pending in the application 4a) Of the above claim(s) 45-48 is/are withdraw Claim(s) is/are allowed. Claim(s) 37-44 is/are rejected. Claim(s) is/are objected to. Claim(s) are subject to restriction and/or	n from consideration.				
Applicat	ion Papers	•				
9)[_ 10)[_	The specification is objected to by the Examine The drawing(s) filed on is/are: a) acceed a Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct The oath or declaration is objected to by the Examine	epted or b) objected to by the drawing(s) be held in abeyance. ion is required if the drawing(s) is	See 37 CFR 1.85(a). objected to. See 37 CFR 1.121(d).			
Priority (ınder 35 U.S.C. § 119					
12)[a)	Acknowledgment is made of a claim for foreign All b) Some * c) None of: 1. Certified copies of the priority documents 2. Certified copies of the priority documents 3. Copies of the certified copies of the prior application from the International Bureau See the attached detailed Office action for a list	s have been received. s have been received in Applic rity documents have been rece u (PCT Rule 17.2(a)).	cation No eived in this National Stage			
Attachmen	• •	🗀				
2) Notic 3) Infon	te of References Cited (PTO-892) te of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO/SB/08) or No(s)/Mail Date	4) Interview Summ Paper No(s)/Ma 5) Notice of Inform 6) Other:	il Date			

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DETAILED ACTION

Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114 was filed in this application after a

decision by the Board of Patent Appeals and Interferences, but before the filing of a Notice of

Appeal to the Court of Appeals for the Federal Circuit or the commencement of a civil action.

Since this application is eligible for continued examination under 37 CFR 1.114 and the fee set

forth in 37 CFR 1.17(e) has been timely paid, the appeal has been withdrawn pursuant to 37 CFR

1.114 and prosecution in this application has been reopened pursuant to 37 CFR 1.114.

Applicant's submission filed on 6/26/2007 has been entered.

Election/Restrictions

2. Newly submitted claims 45-48 are directed to an invention that is independent or distinct

from the invention originally claimed for the following reasons: An election with traverse to

prosecute the method and withdraw the claims drawn to the apparatus and product had been

previously made and affirmed by applicant, see the Non-final rejection filed on 11/8/2002 and

the remarks filed 3/10/2003.

Since applicant has received an action on the merits for the originally presented

invention, this invention has been constructively elected by original presentation for prosecution

on the merits. Accordingly, claims 45-48 are withdrawn from consideration as being directed to

a non-elected invention. See 37 CFR 1.142(b) and MPEP § 821.03.

Claim Rejections - 35 USC § 103

3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

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This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

4. Claims 37-43 are rejected under 35 U.S.C. 103(a) as being unpatentable over Nishizawa et al (US 5,693,139) in view of Edmond et al (US 5,739,554).

Nishizawa et al discloses a method of growing doped semiconductor monolayers, note entire reference, comprising raw material gases of Gallium (Ga) and Arsenic (As), where Ga is supplied for 0.5 to 10 seconds, the chamber is evacuated, this clearly suggests applicant's purged for a predetermined time, and As is supplied for 2 to 200 seconds and the cycle is repeated (col 7, ln 1-67; col 8, ln 1-30 and Fig 7B and Fig 11). Nishizawa et al also discloses a p-type layer is formed by introducing an impurity gases and Ga simultaneously but alternately with an As source, where the impurity gas is an Mg, Zn or Cd containing gas or Silane. Nishizawa et al also discloses a n-type layer doped with Se or S and the impurity gas is introduced cyclically with the Ga gas and As gas or the impurity gas and Ga gas are introduced simultaneously but alternately with the As gas (col 8, ln 31-60). Nishizawa et al also discloses forming pnp bipolar transistors (col 8, ln 61-67). Nishizawa et al also discloses nozzles 44, 45 and 46 for introducing gaseous compounds used for impurity doping for introducing group II, IV and VI gases (col 10, ln 50-67). Nishizawa et al also discloses different modes of doping, where the dopant is added at the exhaustion of an As gas, the introduction of a Ga gas, the exhaustion of a Ga gas or at the introduction of As gas (col 11-13 and Fig 11). Nishizawa et al also discloses other III-V semiconductors are applicable to the invention (col 14, ln 5-55). Nishizawa et al also discloses introduction of a Ga source gas and a group II dopant simultaneously to form a p-type layer (col 8, ln 30-45) and the introduction of a group IV dopant after the introduction of a Ga source gas (col 15, ln 5-50). Nishizawa et al also discloses selection of the timing of doping with respect of the source gas introduction is based on the desired dopant type for the monolayer being grown (col 15, ln 45-55). Nishizawa et al teaches supplying reactants for a short period of time (col 11, ln 50-60), this clearly suggests applicants pulsed manner.

Nishizawa et al does not disclose the given time for supplying each of the impurity raw materials are close to each other.

Edmond et al teaches a gallium nitride (GaN) layer co-doped with both a Group II acceptor and Group IV donor (col 4, ln 50-67), where the group II acceptors include Zn or Mg and the Group IV donors include Si or Ge (col 6, ln 20-50), this clearly suggests applicant's time for supplying each of the impurity raw materials are close to each other. Edmond et al also discloses the GaN layer is formed by CVD, where Trimethylgallium (TMG), ammonia, silane and biscyclopentadienyl magnesium, (Cp)₂Mg are used as reactant gases (col 7, ln 45-67 and col

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8, ln 1-50). It would have been obvious to a person of ordinary skill in the art at the time of the invention to modify Nishizawa et al with Edmond et al's co-doping to form a co-doped GaN layer useful as an active layer (Abstract).

Referring to claim 37, the combination of Nishizawa et al and Edmond et al taches supplying different doping types of impurity raw materials at close timings ('554 teaches codoping) in a pulsed manner within one cycle wherein all types of the crystal raw materials are supplied in one time each in the case when plural types of the crystal raw material are alternately supplied in a pulsed manner with maintaining predetermined purge times ('139 Fig 11).

Referring to claims 38-39, the combination of Nishizawa et al and Edmond et al teaches co-doping using two different impurities, which clearly suggests applicant's close timing in a pulsed manner at the same time.

Referring to claim 40, the combination of Nishizawa et al and Edmond et al teaches forming a co-doped GaN layer using Mg and Si dopant, where the compound semiconductor layer is grown in monolayer by alternate introduction of source gases and the chamber being evacuated continuously throughout the whole method ('139 col 3, ln 35-45) and the Si is introduced after the Ga source gas to act as a donor and a Ga source and a Mg dopant are introduced simultaneously but alternately with a As source.

Referring to claim 41, the combination of Nishizawa et al and Edmond et al teaches the introduction of a group IV dopant after the introduction of Ga and prior to the introduction of As and the introduction of group II dopant after the introduction of Ga and prior to the introduction of As (col 13, ln 10-35 and Fig 11).

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Referring to claim 42, the combination of Nishizawa et al and Edmond et al teaches Ga as a first raw material gas and As or N as a second raw material gas.

Referring to claim 43, the combination of Nishizawa et al and Edmond et al teaches a codoped layer with p-type and n-type impurities.

5. Claim 44 is rejected under 35 U.S.C. 103(a) as being unpatentable over Nishizawa et al (US 5,693,139) in view of Edmond et al (US 5,739,554) as applied to claims 37-43 above, and further in view of Manabe et al (US 6,472,690).

The combination of Nishizawa et al and Edmond et al teaches all of the limitations of claim 21, as discussed previously, including using silane as a Si dopant. The combination of Nishizawa et al and Edmond et al does not teach supplying TESi

In a method of forming a gallium nitride compound semiconductor, note entire reference, Manabe et al teaches forming an n⁺ type Gallium nitride layer, using silane or tetraethylsilane (TESi) (Example 4). It would have been obvious to a person of ordinary skill in the art at the time of the invention to modify the combination of Nishizawa et al and Edmond et al with Manabe et al because substituting known equivalents for the same purpose is obvious (MPEP 2144.06).

Response to Arguments

6. Applicant's arguments filed 6/26/2007 have been fully considered but they are not persuasive.

Applicant's arguments regarding the European Patent Office Action is noted but not found persuasive. First, it is noted that the claims are merely being submitted in response to the second office action in the European Patent application and have not been indicated allowable. Second, it is noted that actions taken by the European Patent Office do not bind the United States Patent and Trademark Office. Thirdly, the European Patent office has not used the same grounds of rejection in the instant application. Finally, the Board of Patent Appeal and Interferences has already determined that co-doping would have been obvious to one of ordinary skill in the art. There is nothing presented in the communication from and to the European Patent Office that would rebut that assertion.

In response to applicant's argument that the references fail to show certain features of applicant's invention, it is noted that the features upon which applicant relies (i.e., forming donor-acceptor complexes) are not recited in the rejected claim(s). Although the claims are interpreted in light of the specification, limitations from the specification are not read into the claims. See *In re Van Geuns*, 988 F.2d 1181, 26 USPQ2d 1057 (Fed. Cir. 1993). The claims merely requiring supplying impurities at close timings.

In response to applicant's argument that the references fail to show certain features of applicant's invention, it is noted that the features upon which applicant relies (i.e., a hole concentration of 1E19/cm³ in GaN and a hole concentration of 5E18/cm³ in AlGaN) are not recited in the rejected claim(s). Although the claims are interpreted in light of the specification, limitations from the specification are not read into the claims. See *In re Van Geuns*, 988 F.2d 1181, 26 USPQ2d 1057 (Fed. Cir. 1993). The claims merely requiring supplying impurities at close timings.

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It is noted that the instantly filed claims are broader than the claims which were appealed to the Board of Patent Appeal and Interferences (BPAI). The Board affirmed the Examiner and concluded that the one of ordinary skill in the art would have been lead to supply both the acceptor and donor impurities taught by Edmond in the manner taught by Nishizawa in Nishizawa's process, motivated by a reasonable expectation of successfully growing a layer having pn junctions useful for bipolar transistor structures (note page 11 of the Decision filed 4/27/2007). Therefore, under the same reasoning given by the BPAI, the rejection is maintained.

Conclusion

7. All claims are drawn to the same invention claimed in the application prior to the entry of the submission under 37 CFR 1.114 and could have been finally rejected on the grounds and art of record in the next Office action if they had been entered in the application prior to entry under 37 CFR 1.114. Accordingly, **THIS ACTION IS MADE FINAL** even though it is a first action after the filing of a request for continued examination and the submission under 37 CFR 1.114. See MPEP § 706.07(b). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however,

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will the statutory period for reply expire later than SIX MONTHS from the mailing date of this

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final action.

8. Any inquiry concerning this communication or earlier communications from the examiner

should be directed to Matthew J. Song whose telephone number is 571-272-1468. The examiner

can normally be reached on M-F 9:00-5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Yogendra Gupta can be reached on 571-272-1316. The fax phone number for the

organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

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information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Matthew J Song

Examiner

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MJS

July 27, 2007

SUPERVISORY PATENT EXAMINER

TECHNOLOGY CENTER 1709